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Applicant:  
**Tomoko HONGO et al.**

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**1712**

U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER: /Chun-Cheng Wang/

DATE CONSIDERED 11/06/2008

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /CCW